

Docket Number: 040021-0306208
Client Reference: OPP 030890 US

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

GEON-OOK PARK

Group Art Unit:

Application No.:

Examiner:

Filed: October 2, 2003

Confirmation No.:

For: FABRICATION METHOD OF SEMICONDUCTOR DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. As the above-identified application is being filed after June 30, 2003, and all of the references cited are U.S. patents, no copies are attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed with the application. No certification or fee is required.

Respectfully Submitted,



Glenn T. Barrett
Registration Number 38705

Date: October 2, 2003

PILLSBURY WINTHROP LLP
Telephone: (703) 905-2000
Facsimile: (703) 905-2500
P.O. Box 10500
McLean, VA 22102

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.